



IN THE UNITED STATES  
PATENT AND TRADEMARK OFFICE

**PATENT APPLICATION**

Applicants: Petra SPECHT, Eicke WEBER, Todd WEATHERFORD

Atty. Doc.: UCB3/CIP(B99-025-3)

Serial No. 10/706,610

Filed: November 12, 2003

Group Art Unit: 2826

Confirmation No.: 5874

Examiner: Pert, Evan T.

Title: DOPING-ASSISTED DEFECT CONTROL IN COMPOUND  
SEMICONDUCTORS

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

S I R:

AMENDMENT

*Please  
enter (EP)  
10-29-05*

In response to the Office Action dated April 1, 2005 (Paper No. 0305), please amend the above-identified application as follows:

Amendments to the specification begin on page 2 of this paper.

Amendments to the claims are reflected in the listing of claims which begins on page 5 of this paper.

Amendments to the drawing reflected on page 8 of this paper.

Remarks/Arguments begin on page 9 of this paper.